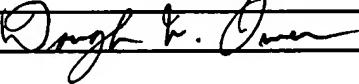


ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	MULTI-LAYER INTEGRATED SEMICONDUCTOR STRUCTURE HAVING AN ELECTRICAL SHIELDING PORTION						
Application Number :	10/749096						
Confirmation Number:	3177						
First Named Applicant:	Rafael Reif						
Attorney Docket Number:	MIT-136DUS						
Art Unit:	3745						
Examiner:							
Search string:	(5523628 or 6717244).pn						
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
RW	1	5523628	1996-06-04	Williams et al.			
RW	2	6717244	2004-04-06	Hikita et al.			
Signature							
Examiner Name				Date			
				1/20/05			

PTO/SB/08A (02-03)

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1

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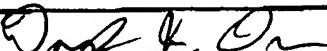
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Complete if Known

Application Number	10/748,096
Filing Date	December 30, 2003
First Named Inventor	Rafael Reif
Art Unit	2811
Examiner Name	Douglas W. Owens
Attorney Docket Number	MIT-136DUS

U. S. PATENT DOCUMENTS				
Examiner Initials*	Cite No.*	Document Number Number-Kind Code ² (If known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
DRW		US- 5,236,118	08/17/1993	Bower et al.
		US- 5,270,281	12/14/1993	Bertin et al.
		US- 5,370,301	12/08/1994	Belcher et al.
		US- 5,391,257	02/21/1995	Sullivan et al.
		US- 5,563,084	10/08/1998	Ramm et al.
		US- 5,669,545	09/23/1997	Pham et al.
		US- 5,985,693	11/16/1999	Leedy
		US- 6,027,958	02/22/2000	Vu et al.
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		US- 6,465,892	10/15/2002	Suga
		US- 2004/0124538	07/01/2004	Reif et al.
		US- 2004/0219765	11/04/2004	Reif et al.
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		US- 2002/0074670	08/20/2002	Suga
		US- 2002/0109238	08/15/2002	Kim et al.
		US- 2002/0135062	09/26/2002	Mastromatteo et al.
		US- 5,706,578	01/13/1998	Hubner
		US- 5,767,009	01/16/1998	Yoshida et al.
		US- 5,825,080	10/20/1998	Imacka et al.

FOREIGN PATENT DOCUMENTS				
Examiner Initials*	Cite No.*	Foreign Patent Document Country Code ² -Number ⁴ -Kind Code ⁵ (If known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
DRW		EP 1 041 624 A1	10/04/2000	Inventronics Microelectronics GmbH vzw
DRW		DE 100 47 963 A 1	03/29/2001	Sony Corp.
DRW		EP 1 432 032 A2	06/23/2004	Infineon Technologies Germany UG (haftungsbeschränkt)
DRW		EP 1 151 962 A1	11/07/2001	STMicroelectronics S.r.l.
DRW		2 645 681 (France)	04/07/1989	Thomson-CSF
DRW		WO 02/09182 A1	01/31/2002	Christian Val

Examiner Signature	Date Considered
	3/23/06

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STATEMENT BY APPLICANT**

STATEMENT BY APPELLEE

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Application Number	10/749,096
Filing Date	December 30, 2003
First Named Inventor	Rafael Reif
Art Unit	2811
Examiner Name	Douglas W. Owens
Initials	MIT-136DUS

SIGNATURE 
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3

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3

Application Number	10/749,096
Filing Date	December 30, 2003
First Named Inventor	Rafael Reif
Art Unit	2811
Examiner Name	Douglas W. Owens
Attorney Docket Number	MIT-136DUS

Sheet

3

of

3

OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS		
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		PCT/US-03/41558 International Search Report dated March 11, 2005
		PCT/US-03/41657 International Search Report dated March 18, 2005
		PCT/US-03/41467 International Search Report dated September 16, 2004
		PCT/US-03/41514 International Search Report dated June 17, 2004
		Y. MAYASHI, S WADA, K. KAJIYANA, K. OYAMA, R. KOH, S. TAKAHASHI, T. KUNIO, Fabrication of Three-Dimensional IC Using "Cumulatively Bonded IC" (CUBIC) Technology, 1990, pp. 85-98, NEC Corporation, Shimokuzawa, Sagamihara, Kanagawa 22, Japan.

Examiner Signature



Date Considered

3/23/06

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